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CONFIRMATION NO. 9347

<b>SERIAL NUMBER</b> 10/500,278	<b>FILING OR 371(c) DATE</b> 06/29/2004 <b>RULE</b>	<b>CLASS</b> 451	<b>GROUP ART UNIT</b> 3723	<b>ATTORNEY DOCKET NO.</b> 120214
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## \* APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/03743 03/26/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-91087 03/28/2002  
 JAPAN 2002-91207 03/28/2002

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 10	<b>TOTAL CLAIMS</b> 37	<b>INDEPENDENT CLAIMS</b> 10
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

## ADDRESS

25944

## TITLE

Double side polishing device for wafer and double side polishing method

<b>FILING FEE RECEIVED</b> 1828	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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